

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/635,100	ISHIBASHI ET AL.	
Examiner	Art Unit	
Joanne H. Kim	2883	

SEARCHED					
Class	Subclass	Date	Examiner		
385	114	3/21/2005	JHK		
385	39	3/21/2005	JHK		
385	12	3/21/2005	JHK		
385	125	3/21/2005	JHK		
· 385	147	3/21/2005	JHK		
250	227	3/21/2005	JHK		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
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DATE	EXMR
3/21/2005	JHK
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